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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. HIROI, et al
Serial No.: 10/062,666
Filed: February 5, 2002
For: PATTERN INSPECTION METHOD AND SYSTEM THEREFOR
Group: 2881
Examiner: K. Fernandez

AMENDMENT

Mail Stop: Amendment (Fee)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 10, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the office action dated September 8, 2004, as listed below and as set forth on the following pages:

Amendment of the Claims;

Remarks are included following the amendments.